

INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

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(5) Several shows if necessary)

Application Number:

10/619,241

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2883

[illegible][illegible]

RAI	-	U.S. Patent Application Publication US 2002/0097962A1 to Yoshimura et al., "Single and Multilayer Waveguides and Fabrication Process", Pub. 7/25/02, Filed 1/22/01, U.S. Cl. 385/50.
RAI	-	U.S. Patent App. Pub. US 2002/0074308A1 to Beguin, "High Precision Alignment of Optical Waveguide Features", Pub. 6/20/02, Filed 12/13/00.
EXAMINER		DATE CONSIDERED
Ryan J. K. 182		8/20/04
		US CLASS 216/2.

**EXPLANATION**

Pub 6/20/02, Filed 12/13 Poo.

DATE CONSIDERED

US CLASS 216/2.

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.